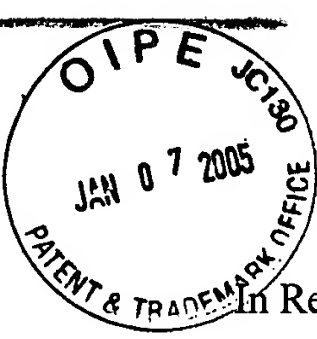


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Attorney Docket SEL 147-CON

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Hisashi OHTANI)
)
Serial No.: 09/916,913)
)
Filed: July 27, 2001)
)
For: Thin Film Transistor Formed)
On A Resin Substrate)
)
Art Unit: 2825)
)
Examiner: L. Malsawma)
)
Confirm no.)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents , P.O. Box 1450, Alexandria, VA 22313-1450 on	
<u>January 4, 2005</u> (Date of Deposit)	
<u>Shannon Wallace</u> Name of applicant, assignee, or Registered Rep.	
<u>Shannon Wallace</u> Signature	<u>1/4/05</u> Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT I (AFTER ALLOWANCE AND PAYMENT OF ISSUE FEE)

Sir:

In response to the Notice of Allowance of September 22, 2004 and in furtherance of Amendment H filed December 22, 2004 with the payment of the issue fee, please amend the above-identified application as follows: